

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
1	IS&R	L1	369	(310/316.03, "319").CCLS.	USPA T	2003/05/2 9 12:30	
2	IS&R	L2	24	(310/316.03, "319").CCLS.	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/05/2 9 12:34	
3	IS&R	L3	247	(310/328).CCLS.	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/05/2 9 12:40	
4	IS&R	L4	1387	(310/328).CCLS.	USPA T	2003/05/2 9 13:41	
5	IS&R	L5	427	(310/338).CCLS.	USPA T	2003/05/2 9 14:08	
6	IS&R	L6	67	(310/338).CCLS.	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/05/2 9 14:11	
7	IS&R	L7	35	(310/339).CCLS.	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB	2003/05/2 9 14:13	
8	IS&R	L8	404	(310/339).CCLS.	USPA T	2003/05/2 9 14:23	
9	IS&R	L9	349	(310/800).CCLS.	USPA T	2003/05/2 9 14:33	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
10	IS&R	L10	17	(310/800).CCLS.	US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB-	2003/05/2 9 14:33	
11	BRS	L11	10	(eap or electroactive adj1 polymer or piezoelectric adj1 polymer) same (sensor or detector or monitor or sensing or detecting or monitoring) and (voltage or current or capacitance or resistance) adj2 change\$ same transducer	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB-	2003/05/2 9 15:00	
12	BRS	L12	335	piezoelectric same (sensor or detector or monitor or sensing or detecting or monitoring) same (voltage or current or capacitance or resistance) adj2 change\$	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB-	2003/05/2 9 15:19	
13	BRS	L13	185	piezoelectric same (sensor or sense or detect or detector or monitor or sensing or detecting or monitoring) same voltage adj2 change\$	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM TDB-	2003/05/2 9 15:23	

	Type	L #	Hits	Search Text	DBs	Time Stamp	Comments
14	BRS	L14	26	piezoelectric same (sensor or sense or detect or detector or monitor or sensing or detecting or monitoring) same voltage adj2 change\$ and (polymer or pvdf or polyvinylidene adj1 fluoride)	USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB	2003/05/2 9 15:27	